

09/925, 747

IFW

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent of:

Confirmation No.: 6652

Kazufumi OGAWA

Group Art Unit: 2879

Patent No.: 6,995,506

Examiner: Joseph L. Williams

Issued: February 7, 2006

For: ORGANIC ELECTRONIC DEVICE, METHOD OF PRODUCING

THE SAME, AND METHOD OF OPERATING THE SAME

PURSUANT TO 37 CFR 1.97(i)

U.S. Patent and Trademark Office Customer Service Window Randolph Building 401 Dulany Street Alexandra, Virginia 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. A copy of the listed references can be found in divisional application Serial No. 11/222,984, filed September 12, 2005.

The references listed on attached Form PTO-1449 were cited in a Search Report mailed December 5, 2005 in the corresponding European application. A copy of the European Search Report is enclosed.

Attorney Docket No. 28951.3088

Inasmuch as this Information Disclosure Statement is filed pursuant to 37 CFR 1.97(i), it is requested that the information contained herein be placed in the file of the captioned patent.

Respectfully submitted,

STEPTOE & JOHNSON LLP

Roger W. Parkhurst

Registration No. 25,177

STEPTOE & JOHNSON LLP 1330 Connecticut Ave., N.W. Washington, D. C. 20036 (202) 429-6420

Attorney Docket No.: 28951.3088

April 9, 2007

APR 0 9 2007

RORM 1449 (S&J Version)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Docket No.: 28951.3088

Applicant: Kazufumi OGAWA

Patent No.: 6,995,506 Issued: February 7, 2006

Examiner: Joseph L. Williams Group Art Unit: 2879

			PATENT DOCUME		I c 1 1	Fire D			
Examiner's Initials*	Document No.	Date MM/YYYY	Inventor	Class	Subclass	Filing Date If Appropriate			
	5,017,975	05/1991	Ogawa et al.	357	8				
•	5,208,111	05/1993	Decher	428	420				
	5,681,442	10/1997	Ogawa et al.	205	122				
	5,698,048	12/1997	Friend et al.	136	263				
	6,060,333	05/2000	Tanaka et al.	438	30				
		FODEL	GN PATENT DOCU	MICNITS					
Examiner's Initials*	Document No.	Date MM/YYYY	Country	Class	Subclas s	Translatio Yes	on No		
IIIIIIII	90/08402	07/1990	wo		 	Abstract	 '''		
	0 481 362 A	04/1992	EP	i	 	Abstract	+		
	0 962 984 A	12/1999	EP	<u> </u>	 		\dashv		
	0 902 904 A	12/1999	LI.	···-			+		
		C	THER DOCUMENT	rs	<u>.</u>				
Examiner's	Inclu		of article, title of item (book		g, etc.), date	, page(s),			
Initials*	volume-issue number(s), publisher, city and/or country where published.								
-	Hiroaki Tachibana, Elsevier-Sequoia S	, et al., "Photores . A. Lausanne, C	ponsive Conductivity in La H, vol. 179, no 1, 11 Nover	ingmuir-Blodget mber 1989, page	tt Films," Thes 207-213	nin Solid Films,			
		on surfaces," ZI	ientation and electronic stru EITSCHRIFT FUR PHYSIA 7, pages 87-102						
	Miyashita T., et al. "Preparation of photofunctional polymer thin films by Langmuir-Blodgett Technique," Chinese Journal of Polymer Science, vol. 17, no. 1, 1999, pages 75-79								
	NG W. Y., et al., "Synthesis and Photoconducting Properties of Poly (Rho-Phenylenevinyle) Containing a Bis(terpyridine) Ruthenium (II) Complex," Advanced Materials, VCH, Verlagsegesellschaft, Weinheim, DE, vol. 9, no. 9, 04 July 1997, pages 716-719								
	Shimidzu T,. et al.; "Porphyrin Arrays Connected with Molecular Wire," Thin Solid Films, Elsevier-Sequoia S. A Lausanne, CH, vol. 273, no. ½, 01 February 1996, pages 14-19								
	Sirringhaus, H. et al., "Integrated, High-Mobility Polymer Field-Effect Transistors Driving Polymer Light- Emitting Diodes," Synthetic Metals, Elsevier Sequoia Lausanne, CH, vol. 102, June 1999, pages 857-860								
	Sung Myung, M. et al., "Formation of alkylsiloxane self-assembled monolayers on Si3N4," JOURNAL OF VACUUM SCIENCE AND TECHNOLOGY A. VACUUM, SURFACES AND FILMS, AMERICAN INSTITUTE OF PHYSICS, NEW YORK, NY, US, vol. 17, no. 2, March 1999, pages 540-544								
					,				

Examiner's	 Date Considered	
Signature		

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.